

<b>Notice of References Cited</b>	Application/Control No. 10/593,036		Applicant(s)/Patent Under Reexamination SUZUKI ET AL.	
	Examiner HRAYR A. SAYADIAN		Art Unit 2814	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,846,927 A	07-1989	Takahashi, Toru	117/17
*	B	US-4,987,094 A	01-1991	Colas et al.	257/185
*	C	US-5,434,100 A	07-1995	Nakamura et al.	117/101
*	D	US-2004/0214407 A1	10-2004	Westhoff et al.	438/459
*	E	US-7,304,310 B1	12-2007	Shortt et al.	250/372
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Mirror Polishing of InP ..., " by "Morisawa," Applied Surface Science, v. 92, (1996), pp. 147-150
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.